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IAP11 Rec'd PCT/PTO 17 JUL 2006 Sheet 1 of 1

INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)			ATTY. DOCKET NO. IPA-011	U.S. APPLICATION NO. Not yet assigned		
			APPLICANT Tomonori FUJISAWA et al			
			FILING DATE herewith	GROUP		
U.S. PATENT DOCUMENTS						
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
<i>DP</i>	5,311,867	05/17/1994	Kynor	—	—	01/04/1993
FOREIGN PATENT DOCUMENTS						
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation
						Yes
<i>DP</i>	2003-150718	05/23/2003	Japan	—	—	abstract
<i>DP</i>	2003-125097	04/25/2003	Japan	—	—	abstract
<i>DP</i>	2002-261955	09/13/2002	Japan	—	—	abstract
<i>DP</i>	2003-109160	04/11/2003	Japan	—	—	abstract
<i>DP</i>	2003-141667	05/16/2003	Japan	—	—	abstract
<i>DP</i>	2003-087436	03/20/2003	Japan	—	—	abstract
<i>DP</i>	2003-111735	04/15/2003	Japan	—	—	abstract
<i>DP</i>	H11-284711	10/15/1999	Japan	—	—	abstract
<i>DP</i>	2003-218997	07/31/2003	Japan	—	—	abstract
<i>DP</i>	2003-219062	07/31/2003	Japan	—	—	abstract
<i>DP</i>	2001-236583	08/31/2001	Japan	—	—	abstract
<i>DP</i>	2000-262480	09/26/2000	Japan	—	—	abstract
<i>DP</i>	H06-277190	10/04/1994	Japan	—	—	abstract
<i>DP</i>	2003-298756	10/17/2003	Japan	—	—	abstract
<i>DP</i>	2001-112725	04/24/2001	Japan	—	—	abstract
<i>DP</i>	H07-311622	11/28/1995	Japan	—	—	abstract
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)						
EXAMINER	DATE CONSIDERED					
<i>David P. Neal</i>						10-5-2007

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.